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research development consulting



#### E E LASER ZENTRUM HANNOVER e.V.

## **Property variations of Laser** components under vacuum conditions

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# Thin Film Technology Department







## **Process Development**



#### **Thermal Processes**

E-beam and boat evaporation Consulting and Implementation for industrial production **Coatings for deep-UV and vacuum-UV applications** 

### Ion Assisted Deposition (IAD)

Characterization and optimization of ion sources Process monitoring and controlling Rapid manufacturing, MIR-spectral range





#### Ion Beam Sputtering (IBS)

Low optical losses, dense layer system High power edge filters, Rugate filters **Precision IBS coating technology** 









# Coatings

## **Production of custom-requested coatings**

#### Spectral range 130nm to 5µm Small batch sizes, special requirements

- optical performance, low losses
- damage threshold, stability
- complex spectral requirements

## Special substrates and materials

- complex geometries
- Iaser and nonlinear crystals
- fiber and laser diode facets
- special coating materials









## **Optics Characterization**



### Damage threshold ISO 11254

157 nm, 193 nm 780 nm (ultra-short pulses), 1064 nm single and multiple-pulse testing

**Absorptance ISO 11551** 355nm, 532 nm, 1064 nm, 10.6 μm

**Total scattering ISO 13696** 157 nm, 193 nm, 633 nm, 1064 nm

**Spectrophotometry ISO 15368** 120 – 240 nm, 190 – 3200 nm, 2.5 – 25 μm

**Precise Reflectometry ISO 13697** 532nm, 1064 nm, 10.6 μm

Development of standard characterization procedures (DIN, CEN und ISO)





## What changes?

## Spectral behavior

## Damage threshold

(measurement according ISO11254)



•Spectral curves of a HR1064 coated in a conventional electron beam process  $[(HL)_{19}H - Ta_2O_5/SiO_2]$ . The spectrum significantly shifts to shorter wavelength under vacuum conditions.

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•Damage threshold decreases strongly in vacuum!!!



# Changing of the spectral behavior

- Method: spectral photometrical measurement in the coating plant (BBM).
- Method: spectral photometrical measurement of thermal shift in with a special heating set-up.







# Where is the water located in the layer?

#### Focus on the physical absorption

(The chemical bounding of hydroxide molecules on the silica is also possible.)



## Porous microstructure

Including of water in the structure
Changing of the refractive index
Absorption in the infrared
Obviously, changes of the laser light resistance



Demanded of layers with a higher density of the microstructure







# **Coating processes**



IAD- Coating plant

- •Water free optics for the MIR-application
- •Shift free
- •Optionally stress free
- •But: Contamination???→ Test of different Ion sources (APS, Lion, Denton CC105)

- IBS- Coating plantLow loss optics (laser gyro mirror)
- •Crystal coatings
- •High power (Rugate)
- •Shift free, water free

esa

•But: High stress





# **Results of shift measurements**

## Vacuum shift of a HR1064 conventional

#### Vacuum shift of AR-coatings



time [s]

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0,1 electron beam ion assisted Ion beam sputter 0.01 1E-3  $-\Delta\lambda/\lambda$ 1E-4 1E-5 2 3 4 5 6 7 8 9 10 11 12 1 Sample

Vacuum shift overview

- •The samples have shown different behaviors during evacuation and venting.
- •The vacuum shift of IBS-samples is negligible. For
- IAD –samples the vacuum shift depends on the Ion dose.
- Time of relaxation is in the range of 1 to 5 hours.
- The relative accuracy of the measurement is 1E-3.



## **Thermal Shift Measurement**



Wavelength[nm]

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Thermal shift reveals the content of water. The results correspond with the spectral measurements in the IR.
Problem of thermal shift measurement is the annealing of the samples.



# Damage of samples under vacuum conditions



In air the LIDT is stable at 20 J/cm<sup>2</sup>. In vacuum the LIDT decreases dramatically. The damage threshold is relatively low, but environment conditions do not have an influence on the LIDT.



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IBS-Coating The increasing LIDT can be achieved using alternative coating materials. Vacuum test are planned.

#### IAD:

The damage threshold is in the range of e<sup>-</sup> - beam coatings. Vacuum test are planned.





## Summar Vacuum shift overview

- Vacuum and thermal shift measurement have shown spectral shifts.
- Coatings of different processes were tested
- Coating properties change under vacuum conditions









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